ATTORNEY DOCKET NO. TI-35029 (032350.B541)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Antonio L.P. Rotondaro

Serial No.:

Unassigned

Filing Date:

December 15, 2003

Title:

Method Of Fabricating A Dielectric Layer For

A Semiconductor Structure

MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

Applicant respectfully requests, pursuant to 37 C.F.R. §§1.56, 1.97, and 1.98, that the document listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application. Furthermore, pursuant to 37 C.F.R. §§1.97(g) and (h), Applicant makes no representation that this document qualifies as prior art or that this document is material to patentability of the present application or that a search has been made.

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PATENT APPLICATION

Since the present Application was filed after June 30, 2003, a copy of any U.S. Patent and any U.S. Patent Application Publication cited on the attached PTO Form 1449 is not being submitted with this Information Disclosure Statement pursuant to the July 11, 2003

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waiver of 37 C.F.R. S 1.98(a)(2)(i) by the U.S. Patent and Trademark Office.

Respectfully submitted,

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Date: December 15, 2003

Customer Number: 23494

Patent Trademark Office

• • • Page 1 of 1 Applicant(s) Application No. PTO-1449 Antonio L.P. Rotondaro Unknown **Information Disclosure Citation** Docket Number Group Art Unit Filing Date In an Application TI-35029 December 15, 2003 Unknown (032350.B541) **U.S. PATENT DOCUMENTS** DOCUMENT NO. DATE **NAME CLASS SUBCLASS** FILING DATE Ā 2003/0109146 A1 06/12/2003 Luigi, et al. 438 769 01/31/2002 В С D E F G Η I J K L M FOREIGN PATENT DOCUMENTS TRANSLATION **SUBCLASS** DOCUMENT NO. DATE **COUNTRY CLASS** YES NO N 0 P Q DATE **DOCUMENT (Including Author, Title, Source, and Pertinent Pages)** R S

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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